

<b>Notice of References Cited</b>		Application/Control No. 10/551,913	Applicant(s)/Patent Under Reexamination LAIHO ET AL.	
		Examiner ICHIEH CHENG	Art Unit 4183	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-2004/0157629	08-2004	Kallio et al.	455/466
*	B US-6,373,817	04-2002	Kung et al.	370/217
*	C US-5,892,811	04-1999	Ambruster et al.	379/7
*	D US-2002/0151992	10-2002	Hoffberg et al.	700/83
E	US-			
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

**FOREIGN PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
O					
P					
Q					
R					
S					
T					

**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	
V	
W	
X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))  
 Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.